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APPLICATION NO.	FI	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/774,011	02/06/2004		Guanghua Wu	356952001300	8420	
25226	7590	06/30/2005		EXAM	EXAMINER	
MORRISON 755 PAGE M		ERSTER LLP	СНАРМАМ	CHAPMAN JR, JOHN E		
PALO ALTO, CA 94304-1018				ART UNIT	PAPER NUMBER	
				2856	<u> </u>	

DATE MAILED: 06/30/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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•		Application No.	Applicant(s)				
		10/774,011	WU ET AL.				
	Office Action Summary	Examiner	Art Unit				
		John E. Chapman	2856				
Period fo	The MAILING DATE of this communica r Reply	tion appears on the cover she	et with the correspondence add	lress			
THE N - Exten after: - If the - If NO - Failur Any n	ORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNICA sions of time may be available under the provisions of 3 (SIX (6) MONTHS from the mailing date of this communic period for reply specified above is less than thirty (30) deperiod for reply is specified above, the maximum statute to reply within the set or extended period for reply will eply received by the Office later than three months after the patent term adjustment. See 37 CFR 1.704(b).	ATION. 7 CFR 1.136(a). In no event, however, nation. ays, a reply within the statutory minimum by period will apply and will expire SIX (6 by statute, cause the application to become	nay a reply be timely filed of thirty (30) days will be considered timely.) MONTHS from the mailing date of this conme ABANDONED (35 U.S.C. § 133).				
Status							
1)🖂	Responsive to communication(s) filed of	on <i>07 June 2005</i> .					
′=	•	☐ This action is non-final.					
3)□	Since this application is in condition for	allowance except for formal	matters, prosecution as to the	merits is			
	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Dispositi	on of Claims						
5)□ 6)⊠ 7)□	Claim(s) <u>1-30</u> is/are pending in the app 4a) Of the above claim(s) <u>16-30</u> is/are v Claim(s) is/are allowed. Claim(s) <u>1-15</u> is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction	vithdrawn from consideration					
Applicati	on Papers						
9) 🗌 -	The specification is objected to by the E	xaminer.					
10)	The drawing(s) filed on is/are: a	□ accepted or b)□ objecte	d to by the Examiner.				
	Applicant may not request that any objection	•	•				
	Replacement drawing sheet(s) including the The oath or declaration is objected to by	· ·		• •			
Priority u	nder 35 U.S.C. § 119						
a)[Acknowledgment is made of a claim for All b) Some * c) None of: 1. Certified copies of the priority do: 2. Certified copies of the priority do: 3. Copies of the certified copies of the application from the International see the attached detailed Office action for	cuments have been received cuments have been received the priority documents have to Bureau (PCT Rule 17.2(a)).	in Application No Deen received in this National S	Stage .			
Attachment							
	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO		view Summary (PTO-413) er No(s)/Mail Date				
3) 🔀 Inform	r No(s)/Mail Date 5/18/04; 5/12/05.		e of Informal Patent Application (PTO-	·152)			

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DETAILED ACTION

1. Applicant's election without traverse of the invention of Group I in the reply filed on June 7, 2005 is acknowledged. Claims 16-30 are withdrawn from further consideration pursuant to 37 CFR 1.142(b) as being drawn to a nonelected invention, there being no allowable generic or linking claim.

2. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

3. Claim 12 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

It is not clear how the proximal end of the suspended structure is secured to the anchor region "opposite substantially an entire length of the first side of the first recessed region." The proximal end 104-1 in Fig. 1B appears to extend along only a fraction of a first side of the recessed portion 132 and not along an entire length of the first side of the recessed region.

4. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

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5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all

obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person

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having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the

manner in which the invention was made.

6. Claims 10, 12 (as best understood), 13 and 15 are rejected under 35 U.S.C. 102(b) as

being clearly anticipated by Iwata et al.

Iwata et al. discloses a micromechanical device comprising a first semiconductor layer 2

having a first recessed region 3 formed therein and a cantilever beam 5 formed in semiconductor

layer 6 secured to the first wafer. Iwata et al. further discloses in Fig. 12b a proof mass 33 and

flexure region 32 that is thin relative to the anchor region, and further teaches that the proof mass

33 may be formed on the lower side of the end portion of the cantilever beam 5 (column 11, lines

34-37).

Regarding claim 12, the proximal end of the cantilever 5 extends along substantially an

entire length of the first side of recessed region 3.

Regarding claim 13, the seismic mass comprises the proof mass 33 in a first sublayer 35

as well as a cantilever portion 5 in a second sublayer 37.

7. Claims 1-6, 11, 13 and 14 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the

alternative, under 35 U.S.C. 103(a) as obvious over Iwata et al.

The only difference, if any, between the claimed invention and the prior art consists in

forming a flexure region that is thin relative to the anchor region. Iwata et al. appears to teach

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forming the cantilever beam 5 in Fig. 1 from a proof mass 33 and flexure region 32 that is thin relative to the anchor region as shown in Fig. 12b, and, if not, it would have been obvious to form a flexure region 32 that is thin relative to the anchor region in the same manner as shown in Fig. 12b when forming the proof mass 33 on the lower side of the end portion of the cantilever beam 5.

Regarding claims 6 and 13, the first sublayer 35 and second sublayer 37 define the proof mass 33.

8. Claims 7-9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Iwata et al. as applied to claim 1 above, and further in view of Takebe et al.

The only difference between the claimed invention and the prior art consists in forming a second recessed region and forming a diaphragm opposite the second recessed region. Takebe et al. discloses a cantilever in Fig. 1(a) and a diaphragm in Fig. 1(b) and teaches forming a semiconductor sensor having both a cantilever for sensing acceleration and a diaphragm for sensing pressure (column 4, lines 10-15). It would have been obvious to one of ordinary skill in the art to provide the apparatus of Iwata et al. with a second recessed region and a diaphragm opposite the second recessed region in order to form a semiconductor sensor having both a cantilever for sensing acceleration and a diaphragm for sensing pressure, as taught by Takebe et al.

9. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Shinohara discloses a micromechanical device in Fig. 5 comprising a lower stopper

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26 having a first recessed region formed therein and a cantilever beam 23 having a flexure region

22 formed in a semiconductor layer 21.

10. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to John E. Chapman whose telephone number is (571) 272-2191. If

attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Hezron

Williams can be reached on (571) 272-2208. The fax phone number for the organization where

this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

ohn E Chapman Primary Examiner